

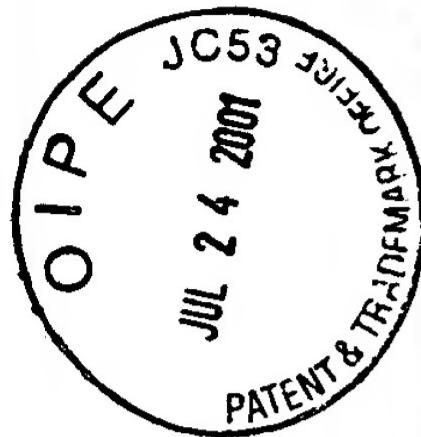
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Receipt

#2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yoo, Woo Sik
Assignee: WaferMasters Incorporated
Title: Method For Ultra Thin Film Formation
Serial No.: 09/775,835 Filing Date: January 31, 2001
Examiner: To Be Assigned Group Art Unit: 2812
Docket No.: M-8250 US



Newport Beach, California
July 24, 2001

ASSISTANT COMMISSIONER FOR PATENTS
Attn: Zenebework Moguss
Office of Initial Patent Examination
Customer Service Center
Washington, D. C. 20231

REQUEST FOR CORRECTED FILING RECEIPT

Dear Sir/Madam:

Applicants hereby request the Commissioner For Patents to correct the Official Filing Receipt for the above-identified patent application as follows:

- 1. Correct the Filing Date
- 2. Correct Inventor Name
- 3. Correct Title
- 4. Correct information referencing related case
- 5. Correct Attorney Docket Number
- 6. Other: _____

This Request is submitted for the following reasons:

The title of the invention should read "Method for **ultra thin** film formation," rather than "Method for ultra-thin film formation."

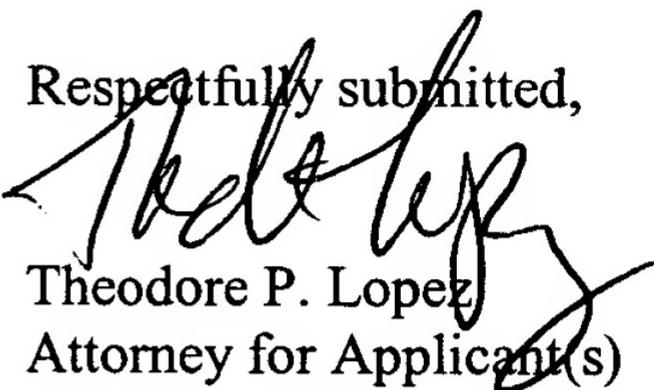
LAW OFFICES OF
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Attached is a copy of the Filing Receipt having the above errors and the changes noted thereon, as well as copy of the Declaration showing the correct title. Therefore, it is respectfully requested that a corrected Filing Receipt be issued. Because this was not an error on the part of Applicant(s), Applicant(s) believe no fee is required.

If this action does not lead to issuance of a corrected Official Filing Receipt as requested, please contact the undersigned at (949) 718-5200.

EXPRESS MAIL LABEL NO:
EL661717785US

Respectfully submitted,


Theodore P. Lopez
Attorney for Applicant(s)
Reg. No. 44,881

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UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/775,835	01/31/2001	2812	364	M-8250 US	5	21	3

CONFIRMATION NO. 1153

UPDATED FILING RECEIPT



OC00000006108951

Theodore P. Lopez
SKJERVEN MORRILL MacPHERSON LLP
Suite 700
25 Metro Drive
San Jose, CA 95110-1349

Date Mailed: 05/23/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Woo Sik Yoo, Palo Alto, CA;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted 03/12/2001

Projected Publication Date: 08/01/2002

Non-Publication Request: No

Early Publication Request: No

**** SMALL ENTITY ****

Title

Method for ultra thin film formation

Preliminary Class

438

Data entry by : MOGUSS, ZENEBEWORK

Team : OIPE

Date: 05/23/2001





**DECLARATION FOR PATENT APPLICATION
AND POWER OF ATTORNEY**

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below adjacent to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of subject matter (process, machine, manufacture, or composition of matter, or an improvement thereof) which is claimed and for which a patent is sought by way of the application entitled

Method for Ultra Thin Film Formation

- which (check) is attached hereto.
 and is amended by the Preliminary Amendment attached hereto.
 was filed on as Application Serial No.
 and was amended on (if applicable).

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information, which is material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56.

I hereby claim foreign priority benefits under Title 35, United States Code, § 119(a)-(d) of any foreign application(s) for patent or inventor's certificate or any PCT international application(s) designating at least one country other than the United States of America listed below and have also identified below any foreign application(s) for patent or inventor's certificate or any PCT international application(s) designating at least one country other than the United States of America filed by me on the same subject matter having a filing date before that of the application(s) of which priority is claimed:

Prior Foreign Application(s)			Priority Claimed	
Number	Country	Day/Month/Year Filed	Yes	No
N/A			<input type="checkbox"/>	<input type="checkbox"/>

I hereby claim the benefit under Title 35, United States Code, § 119(e) of any United States provisional application(s) listed below:

Provisional Application Number	Filing Date
N/A	

I hereby claim the benefit under Title 35, United States Code, § 120 of any United States application(s) or PCT international application(s) designating the United States of America listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior application(s) in the manner provided by the first paragraph of Title 35, United States Code, § 112, I acknowledge the duty to disclose information, which is material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56, which became available between the filing date of the prior application(s) and the national or PCT international filing date of this application:

Application Serial No.	Filing Date	Status (patented, pending, abandoned)
N/A		

COPY

I hereby appoint the following practitioners to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith:

Customer Number 24251



Please address all correspondence and telephone calls to:

Theodore P. Lopez
SKJERVEN MORRILL MacPHERSON LLP
25 Metro Drive, Suite 700
San Jose, California 95110-1349

Telephone: 408-453-9200
Facsimile: 408-453-7979

I declare that all statements made herein of my own knowledge are true, all statements made herein on information and belief are believed to be true, and all statements made herein are made with the knowledge that whoever, in any matter within the jurisdiction of the Patent and Trademark Office, knowingly and willfully falsifies, conceals, or covers up by any trick, scheme, or device a material fact, or makes any false, fictitious or fraudulent statements or representations, or makes or uses any false writing or document knowing the same to contain any false, fictitious or fraudulent statement or entry, shall be subject to the penalties including fine or imprisonment or both as set forth under 18 U.S.C. 1001, and that violations of this paragraph may jeopardize the validity of the application or this document, or the validity or enforceability of any patent, trademark registration, or certificate resulting therefrom.

Full name of sole (or first joint) inventor: Woo Sik Yoo

Inventor's Signature: Woo Sik Yoo

Date: 1/26/01

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